

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

BRYAN P. STAKER, et al.

Application No.: Unassigned

Filed: Herewith

For: MEMS STRUCTURE WITH
MECHANICAL OVERDEFLECTION
LIMITER

Examiner: Unassigned

Technology Center/Art Unit: Unassigned

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.